



1765 H/TP
CC

500.41295X00

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): T. KAWAGUCHI, et al
Serial No.: 10/083,252
Filed: February 27, 2002
For: PLASMA PROCESSING METHOD AND APPARATUS
Group: 1765
Examiner: S. Ahmed

AMENDMENT

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

June 9, 2004

Sir:

In response to the Office Action dated January 9, 2004, the following amendments and remarks are respectfully submitted in connection with the above-identified application, as listed below and as set forth on the following pages:

Amendment of the Specification and Abstract;

Amendment of the Claims;

Remarks are included following the amendments;

Amendments to the Drawings describing changes to the drawings shown in the Appendix; and

An Appendix including amended drawing figures is attached following the Remarks.